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PATENT

IN THE UNITED STATES PATENT AND
TRADEMARK OFFICE

Applicant: ROBERT D. HORNING, ET AL Group: 1746
Serial No.: 09/873,931 Examiner: ~~Unknown~~ Alantco
Filed: 06/04/01 Docket No. H16-16009 US
Title: APPLICATIONS OF A STRAIN-COMPENSATED HEAVILY DOPED ETCH
STOP FOR SILICON MICROMECHANICAL STRUCTURE FORMATION

PRELIMINARY AMENDMENT

Assistant Commissioner For Patents
Washington, D.C. 20231

Dear Sir:

Please enter this amendment into the present application.

IN THE SPECIFICATION

Please insert after the title and before the first paragraph,

AI --The Government may have rights in this invention pursuant to Contract No. N00030-94-C-001,
awarded by the Department of the Navy.--

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Respectfully submitted,
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